2018년 2월 6일(화), 09:00-10:45 Room I (청옥II+III, 6층)

## K. Memory (Design & Process Technology) 분과 [TI1-K] ReRAM I - Preparing for Mass Production

좌장: 김수길 수석(SK 하이닉스), 백승재 교수(한경대학교)

	[초청]
	Highly Reliable Multi-Bit Operation in HfO <sub>2</sub> Based Resistive Switching
TI1-K-1	Device
09:00-09:30	Gun Hwan Kim, Ji Woon Choi, Bo Keun Park, Taek-Mo Cheong, and Young Kuk
	Lee
	Center for Thin-Film Materials, KRICT
	Roles of Conducting Filament and Non-Filament Regions in the Ta <sub>2</sub> O <sub>5</sub> and
	HfO <sub>2</sub> Resistive-Switching Memory for Switching Reliability
	Tae Hyung Park <sup>1</sup> , Hae Jin Kim <sup>1</sup> , Soo Gil Kim <sup>2</sup> , Byung Joon Choi <sup>3</sup> , and Cheol Seong
TI1-K-2	Hwang <sup>1</sup>
09:30-09:45	<sup>1</sup> Department of Materials Science and Engineering and Inter-University
	Semiconductor Research Center, Seoul National University, <sup>2</sup> SK Hynix
	Inc., <sup>3</sup> Department of Materials Science and Engineering, Seoul National University
	of Science and Technology
	Controlling Filament Forming Direction of Restive Switching Memory
TI1-K-3	Device via Nanomesh Patterning
09:45-10:00	Tae Jin Kim, Byoung Kuk You, Jong Min Kim, Daniel J. Joe, and Keon Jae Lee
	Department of Material Science and Engineering, KAIST
	Department of Waterial Science and Engineering, KAIST
	Selector for Bipolar Resistive Switching Material Having Current Saturation
	Functionality with Pt/Ti/TiO <sub>2</sub> /HfO <sub>2</sub> /TiN Device
TI1-K-4	Daeeun Kwon, Jung Ho Yoon, Tae Hyung Park, Yumin Kim, Young Jae Kwon, Hae
10:00-10:15	Jin Kim, and Cheol Seong Hwang
	Department of Materials Science and Engineering and Inter-university
	Semiconductor Research Center, Seoul National University
TI1-K-5	저항 변화층의 Initial Current Level과 저항 변화 특성
10:15-10:30	김명주, 한언빈, 김태우, 이한춘, 이상기, 이윤종
10.13 10.30	DB Hitek, 특화공정개발파트